



In re application of:

Zvi OR- BACH et al.

Art Unit: 2826

Application No: 10/730,064-

METHOD FOR FABRICATION OF SEMICONDUCTOR DEVICE

Examiner: Tuan N. QUACH

Confirmation No: 2943

Atty. Docket No: 38897-199163

Filed: December 9, 2003

Customer No:

Information Disclosure Statement

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

For:

This is an Information Disclosure Statement submitted under 37 C.F.R. § 1.97 within the time specified under 37 C.F.R. § 1.97(b).

In order to comply with applicant's duty of disclosure under 37 C.F.R. § 1.56, the U.S. Patent and Trademark Office is notified of the documents which are listed on the attached Form PTO-1449 and which the Examiner may deem relevant to patentability of the claims of the above-identified application. Please note that all of the references listed were either cited in the attached International Search Report and made of record and/or submitted in copending Application No. 10/321,669 and also made of record by the Examiner. Copies are not being submitted. However, if such copies are deemed necessary, please advise the undersigned attorney.

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In view of the above, no further translation or statement of relevance is required, and as all requirements of 37 C.F.R. § 1.97 and all official guide lines pertaining to Information Disclosure Statements have been complied with, and it is therefore respectfully requested that the Examiner consider the documents and make them of record.

The present Information Disclosure Statement is being filed before the mailing date of the first Office Action on the merits. Therefore, no fee is deemed necessary for this submission. If any necessary fees are due, please charge and/or credit any overpayment in connection with this Information Disclosure Statement to Deposit Account No. 22-0261.

Respectfully submitted,

Date: March 21, 2005

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Application Number 10/730,064 Filing Date December 9, 2003 First Named Inventor Zvi OR-BACH et al. Group Art Unit 2826 **Examiner Name** Tuan N. QUACH

Complete if Known

(use as many sheets as necessary)

Sheet of Attorney Docket Number 38897-199163

1 05 - <u><u></u></u>				U.S. PATENT DOCUM	MENTS	
examiner Initials *	Cite No.1	U.S. Patent Document Kind Code ² (if known)		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Releva Passages or Relevant Figures Appear
	A1	US 3,401,126		Lewis F. MILLER et al.	9-10-1968	
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Examiner Initials*	Cite No. ¹	Foreign Patent Document			Name of Patentee	Date of Publication of	Pages, Columns, Lines,		
		Office ³	Number⁴	Kind Code ⁵ (if known)	or Applicant of Cited Document	Cited Document MM-DD-YYYY	Where Relevant Passages or Relevant Figures Appear	Τ ₆	
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Examiner Signature	Date Considered	

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). 4 For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. 5 Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. 6 Applicant is to place a check mark here if English language Translation is attached.



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